



Attorney Docket No. 80585(302765) Ifw

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **YAMADA Toshiro et al.**

Serial No.: **10/520,272**

Group Art Unit: **1765**

Filed: **January 14, 2005**

Examiner: **AHMED, SHAMIM**

P.T.O. Confirmation No.: **4526**

**FOR: METHOD OF DRY ETCHING, DRY ETCHING GAS AND PROCESS FOR
PRODUCING PERFLUORO-2-PENTYNE**

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MAIL STOP: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT UNDER 37 CFR §1.111

*DO NOT
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S&A
9/20/07*

In response to the First Office Action dated June 6, 2007, please amend the above-captioned patent application as follows, as shown in the complete listing of the claims:

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 4 of this paper.